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<td>Ling, CC; Beling, CD; Fung, S</td>
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Isochronal annealing studies of \textit{n}-type 6H-SiC with positron lifetime spectroscopy

C. C. Ling, C. D. Beling, and S. Fung

Department of Physics, The University of Hong Kong, Pokfulam Road, Hong Kong, China

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\textit{n}-type 6H silicon carbide has been studied using positron lifetime spectroscopy with isochronal annealing temperatures of 400, 650, 900, 1200, and 1400 °C. In the as-grown sample, we have identified the $V_{Si}$ vacancy, the $V_{C}V_{Si}$ divacancy, and probably the $V_{C}$ vacancy. The silicon vacancy and the carbon vacancy were found to anneal out in the temperature range 400–650 °C. The $V_{C}V_{Si}$ divacancy was found to persist at an annealing temperature of 1400 °C.

\section{I. INTRODUCTION}

Silicon carbide is a wide-band-gap semiconductor which has attracted considerable attention as a material for high-temperature, high-power, and high-frequency devices. As defects play an important role in influencing the electrical properties of the material, defects in 6H-SiC have been extensively studied with the use of different techniques like deep-level transient spectroscopy (DLTS),\textsuperscript{1-4} electron-spin resonance (ESR),\textsuperscript{5} positron annihilation spectroscopy,\textsuperscript{6-11} and photoluminescence.\textsuperscript{12} A detailed review of the electrical and optical characterization of SiC was given by Pенsl and Choyke.\textsuperscript{13}

With the use of DLTS, a number of deep levels in the SiC band gap have been found in as-grown or irradiated samples. For example, $Z_{1}/Z_{2}$ and $E_{1}/E_{2}$ levels have been observed in many \textit{n}-type 6H SiC studies, like those of Zhang \textit{et al.},\textsuperscript{14} Hemmingsson \textit{et al.},\textsuperscript{2} Gong \textit{et al.},\textsuperscript{3} and Aboelfotoh and Doyle.\textsuperscript{4} However, regarding the interpretation of the microstructures associated with these deep levels, there are presently no consensus. Zhang \textit{et al.}\textsuperscript{14} reported a double peak at $E_{C}−0.62$ eV and $E_{C}−0.64$ eV which they called $Z_{1}/Z_{2}$. The $Z_{1}/Z_{2}$ defect level was proposed to be due to the $V_{C}V_{Si}$ divacancy. The $V_{C}V_{Si}$ site was also previously observed in an ESR study, and it was related to the $D_{1}$ center observed in a photoluminescence study\textsuperscript{12} because they were all stable at an annealing temperature of 1700 °C. However, with DLTS, Aboelfotoh and Doyle\textsuperscript{4} also observed a double peak at the same position, but the defect was found to anneal out at a temperature of 850 °C and was thus suggested to be a silicon vacancy. Gong \textit{et al.}\textsuperscript{3} observed a signal close to the $Z_{1}/Z_{2}$ position, but failed to obtain a reliable position as the signal was too small. The peak was found to be annealed out at a temperature lower than 1150 °C. The authors also pointed out the problem of simply assigning the $Z_{1}/Z_{2}$ levels to the $V_{C}V_{Si}$ divacancy, as its generation rate in the electron irradiation process varies considerably from sample to sample in different studies, although the electron implanting energies were similar (see, for example, Hemmingsson \textit{et al.}\textsuperscript{2} and Zhang \textit{et al.}\textsuperscript{14}).

For the case of $E_{1}/E_{2}$, most studies agree that this level doublet is not annealed out even at temperatures as high as 1600 °C but the assignment of the defect microstructure differed between investigators.\textsuperscript{1,3,4,14} Aboelfotoh and Doyle,\textsuperscript{3} for example, found deep acceptors at $E_{C}−0.34$ eV and $E_{C}−0.41$ eV, and identified them as $E_{1}/E_{2}$. The deep acceptors were assigned to a negatively charged carbon vacancy occupying different sites, and it was suggested that such sites were stable after a 1000 °C annealing. Gong \textit{et al.},\textsuperscript{3} found deep acceptors $ED_{3}$ and $ED_{4}$ at $E_{C}−0.36$ eV and $E_{C}−0.44$ eV respectively. Again, it was pointed out that the $ED_{3}$ and $ED_{4}$ levels were the $E_{1}/E_{2}$ levels as seen by others. Moreover, the $E_{C}−0.36$ eV was found to consist of two overlapping peaks $ED_{3L}$ and $ED_{3H}$. The $ED_{3L}$ level was found to be annealed out at a temperature of 700 °C. It was suggested that the deep levels $ED_{3H}$ and $ED_{4}$ were attributed to the $V_{C}V_{Si}$ divacancy, as they were not completely annealed out at a high temperature of 1600 °C.

Positron lifetime spectroscopy has been used extensively as a nondestructive probe in semiconductors because of its excellent sensitivity toward neutral or negatively charged vacancies.\textsuperscript{15-17} The principle of the positron lifetime technique is based on the fact that vacancies in the semiconductor trap implant positrons into localized states which have a longer positron lifetime compared to delocalized positrons, because the electron density at the vacancy site is lower. Different vacancies can be identified by their characteristic positron lifetimes, which can thus serve as a fingerprint of the defect. Moreover, additional information, such as defect concentration, charge state, and ionization energies of different charge states can often be extracted from positron lifetime data.

In a previous study,\textsuperscript{11} we examined as-grown \textit{n} and \textit{p}-type 6H-SiC with the positron lifetime technique. In \textit{p}-type material, a 225-ps component was found, and was attributed to positron annihilating in neutral $V_{C}V_{Si}$ divacancies. The $V_{C}V_{Si}$ concentration was estimated to be $4 \times 10^{16}$ cm$^{-3}$. For \textit{n}-type 6H-SiC, a 200-ps lifetime component was observed, and this was proposed to be the overlapping of coexisting silicon vacancy and $V_{C}V_{Si}$ divacancy components, which have characteristic lifetimes smaller than and larger than 200 ps respectively. A positron shallow trap was also identified from its low-temperature competition with vacancy trapping. This Rydberg-like state of the positron results from the positron binding with a negative impurity or acceptor. It was also pointed out that in \textit{p}-type material, the Fermi level was close to the valence band, which probably made the silicon vacancy positively charged the acceptor neutrally charged;
thus neither is capable of trapping positrons.

In the present study, we aim to examine previous proposals on defect assignment, and also to study the annealing behavior of the vacancy defects in the material. We have performed positron lifetime measurements on n-type 6H SiC annealed at 400, 650, 900, 1200, and 1400 °C. At each of the annealing temperatures, positron lifetime spectra were accumulated at temperatures ranging from 20 K to room temperature.

II. EXPERIMENT

The material used in the study was a Lely-grown nitrogen-doped research grade n-type 6H silicon carbide wafer purchased from Cree Research Inc. The doping concentration of the wafer was $1.2 \times 10^{18} \text{ cm}^{-3}$. Four samples with a size of $5 \times 8 \text{ mm}^2$ were cut from the wafer, degreased with acetone and methanol, and then rinsed in deionized water. The positron radioactive source was made by encapsulating 20-µCi $^{127}$NaCl with a kapton foil. The source foil was then sandwiched by four pieces of sample with two pieces at a side. The sample assembly was then installed into a closed-cycle He fridge. Each of the lifetime spectra were accumulated up to $4 \times 10^6$ counts, with the standard fast-fast lifetime spectrometer having a resolution of 220 ps. Lifetime measurements were performed on samples annealed at 400, 650, 900, 1200, and 1400 °C. The annealing process was performed in a forming gas environment for a period of 30 min. For each of the annealing temperatures, lifetime spectra were collected at different temperatures from 20 K to room temperature.

III. RESULTS AND ANALYSIS

A positron lifetime spectrum is a linear combination of exponential terms contributing from the corresponding annihilating sites, i.e.,

$$S(t) = N \sum_i \frac{I_i}{\tau_i} \exp \left( -\frac{t}{\tau_i} \right),$$

where $\tau_i$ and $I_i$ are the characteristic lifetime and the intensity of the corresponding component, respectively. The lifetime spectra were decomposed into components by the program POSITRONFIT with all the parameters free.

It was found that in all of the spectra, a three-component fit could give a good representation of the spectra. A nonvarying long lifetime component, having a lifetime value of about 1000 ps at the 1.5% level, was found to exist in spectra irrespective of the annealing temperature and the measurement temperature. This lifetime component was thus attributed to positronium annihilation at voids or at the surface of the sample, and does not fall within the scope of interest of the present study. This component was thus removed, and data analyzed with just two components.

The fitted results of the lifetime parameters $\tau_2$, $\tau_1$ and $I_2$, as a functions of the measurement temperature for the as-grown sample, and that after the 900 °C anneal, are shown in Fig. 1. The sample used in the present study was the same sample as that employed in a previous study. For the as-grown and the 900 °C annealed spectra, the values of $\tau_2$, the characteristic lifetime of the positron trapping center, were essentially constant (with values of about 200 and 230 ps, respectively), at all of the measurement temperatures. This behavior was also true for all other annealing temperatures. This constancy, which was also observed in the annealed samples, implies that there is no change in the defect microstructure as the measurement temperature is lowered from room temperature. The average $\tau_2$ values plotted as a function of annealing temperature are shown in Fig. 2(a), from which it is seen that the mean $\tau_2$ value varies with the annealing temperature. This variation will be discussed below.

In order to eliminate the correlation between the fitting parameters in the fitting process, the spectra were refitted by fixing the $\tau_2$ values according to the values shown in Fig. 2(a). The resulting $I_2$ and $\tau_1$ variation, plotted as a function of the measurement temperature for the different annealed samples, is shown in Fig. 3. For the as-grown sample it is observed that the long lifetime intensity $I_2$ stays at a constant value of about 40% for temperatures above 80 K, but falls to about 12% as the temperature decreases to 10 K. This dropping of $I_2$ at low temperature is accompanied by an increase of $\tau_1$. In Ref. 11, this low-temperature behavior was attributed to a positron shallow trap. A positron shallow trap is a Rydberg state formed by the positron binding to a negatively charged impurity ion, such states having been observed in both GaAs (Ref. 19) and Si. The binding energy of this state varies typically from 10 to 100 meV. Thus the state is thermally detrapped at room temperature, and only plays a significant role at low temperature (i.e., $T<80$ K). From Fig. 3 it is seen that this low-temperature behavior vanishes when the sample is annealed to 650 °C.
A. Long lifetime component ($\tau_2 = 200–232$ ps)

In investigating the annealing behavior of positron trapping, we first consider the variation of $\tau_2$ with annealing temperature. At each annealing temperature, an average value of $\tau_2$ was obtained by averaging the temperature measurement scan data from 80 K to room temperature. With reference to Fig. 2, for the as-grown sample, it can be seen that the defect lifetime $\tau_2$ is $200 \pm 9$ ps. This then increases up to about 225 ps as the annealing temperature is increased up to 650 °C. Only a minor increase in $\tau_2$ is then observed as the annealing temperature further increases up to 900 °C, at which temperature $\tau_2$ has saturated at about 232 ps.

Brauer et al.21 calculated different vacancy type defects in 6H-SiC with the use of the linear muffin orbital in the atomic spheres approximation. The lifetime values of the carbon vacancy, the silicon vacancy, and the Si+C divacancy were calculated to be 153, 191, and 212 ps, respectively. For experimental work, positron lifetime values of $V_{Si}$ and $V_{C}V_{Si}$ have been reported to be 183 ps (Ref. 8) and 235 ps,10 respectively. According to our previous study,11 the 200-ps lifetime component found in the as-grown sample was the overall result of positrons annihilating in the $V_{Si}$ monovacancy and the $V_{C}V_{Si}$ divacancy coexisting in the sample, the lifetime values of $V_{Si}$ and $V_{C}V_{Si}$ being too close to be resolved. This being the case the increase of the observed $\tau_2$ upon annealing up to 650 °C can be explained by the annealing out of the silicon vacancy. The $\tau_2$ value of 232 ps observed at annealing temperatures at 650–1200 °C is thus understood as the lifetime of $V_{C}V_{Si}$. The disappearance of $V_{Si}$ after annealing to 650 °C is close to the observation of Ref. 22, where the $F$ spectrum in an ESR measurement, attributed to $V_{Si}$, was annealed out at 750 °C, which is close to the value observed here.

It is possible to calculate the concentrations of $V_{Si}$ and $V_{C}V_{Si}$ as functions of the annealing temperature. In the higher measurement temperature range, which is free from low temperature traps ($T\approx80$ K), positron trapping into the silicon vacancy and the Si+C divacancy can be described by the simple trapping model with two competing trapping centers. The solution of this model is given by15

$$\lambda_{D2} = 1/\tau_{V_{Si}},$$

$$\lambda_{D3} = 1/\tau_{V_{C}V_{Si}}.$$
where $I_{D2}$ and $I_{D3}$ are the intensities of the two lifetime components corresponding to the silicon vacancy and the Si$^+$C divacancy, respectively, and the $\lambda_{D1}$'s are the respective annihilation rates from the two defect states. $\lambda_b$ is the positron annihilation rate of the bulk. $\kappa_{V_{Si}}$ and $\kappa_{V_{C_{Si}}}$ are the trapping rates into $V_{Si}$ and $V_{C_{Si}}$, respectively.

In the present case, as the lifetime values of the two positron trapping centers are too close to be separated, the observed lifetime would be equal to

$$\tau_{2,exp} = \frac{I_{D2}}{I_{D2} + I_{D3}} \times \frac{1}{\lambda_{D2}} + \frac{I_{D3}}{I_{D2} + I_{D3}} \times \frac{1}{\lambda_{D3}}.$$  

Thus the values of $\kappa_{V_{Si}}$ and $\kappa_{V_{C_{Si}}}$ can be found by solving Eqs. (2)–(6). The lifetime value of $V_{C_{Si}}$ has been reported in studies of ion-implanted 6H SiC (Ref. 21) and as-grown $p$-type 6H-SiC,\textsuperscript{11} and was found to be 235 and 225 ps respectively. The lifetime value of the silicon vacancy was reported to be 185 ps (Ref. 10) and 183 ps.\textsuperscript{8} Therefore, the trapping rates into $V_{Si}$ and $V_{C_{Si}}$ at room temperature as functions of the annealing temperature can be calculated by taking $\tau_{V_{Si}} = 184$ ps and $\tau_{V_{C_{Si}}} = 230$ ps, which are the average values of these previous results.

The calculated room-temperature trapping rates of $V_{Si}$ and $V_{C_{Si}}$ are plotted as function of the annealing temperature in Figs. 2(b) and 2(c). The positron trapping rate is proportional to the defect concentration $\kappa_i = \mu_i c_i$, where $\mu_i$ is the specific trapping coefficient of the defect $i$.\textsuperscript{15} From Fig. 2, it is seen that the trapping rate (and thus the concentration) of $V_{Si}$ dropped from $\kappa_{V_{Si}} = 9.2 \times 10^4 \text{ s}^{-1}$ to zero for annealing temperatures of 650 $^\circ$C or above. In contrast, the trapping rate of $V_{C_{Si}}$ remains essentially constant at about $\kappa_{V_{C_{Si}}} = 10^9 \text{ s}^{-1}$, within statisticalerror over the whole annealing temperature range.

The vacancy and divacancy concentrations can be calculated if the values of their specific trapping coefficient $\mu_{V_{Si}}$ and $\mu_{V_{C_{Si}}}$ are known. Although there are no reports on the experimental or theoretical values of the $\mu_{V_{Si}}$ and $\mu_{V_{C_{Si}}}$ in SiC, the Si vacancy and Si$^+$C divacancy concentrations can still be estimated with the use of the previous findings in Si.\textsuperscript{23,24} As it was reported that $\mu_{V_{Si}} = 1:35$, and $\mu_{V_{C_{Si}}} = 4 \times 10^{10} \text{ s}^{-1}$ in Si,\textsuperscript{23,24} the specific trapping coefficient of neutral Si divacancy in Si was found to be $1.14 \times 10^{11} \text{ s}^{-1}$. With this value, the concentration of the $V_{C_{Si}}$ divacancy can be estimated as $c_{V_{C_{Si}}} = 8.3 \times 10^{16} \text{ cm}^{-3}$.

In calculating the concentration of silicon vacancy, we assume the silicon vacancy in the $n$-type 6H SiC sample is negatively charged. This seems reasonable based on the following: (i) A negatively charged silicon vacancy was observed in 4H SiC with the use of ESR,\textsuperscript{25} and (ii) According to the calculation of Zywietz et al.,\textsuperscript{26} the $(-/0)$ level is close to the midgap position, and the Fermi-level position of the present $n$-type sample is close to the conduction band. Mäkinen et al.\textsuperscript{27} reported a value of about $\mu_{V} = 10^{17} \text{ s}^{-1}$ for the negatively charged Si vacancy at $T = 20$ K. For the negatively charged vacancy, the specific trapping coefficient follows a $T^{-0.5}$ dependence.\textsuperscript{15} Based on these assumptions, the concentration of $V_{Si}$ in the as-grown sample is estimated to be $3.2 \times 10^{15} \text{ cm}^{-3}$.

### B. Low-temperature trap: shallow trap or carbon vacancy?

For the as-grown sample, as shown in Fig. 3, $I_2$ was found to decrease for temperatures below 80 K. This decrease in $I_2$ corresponded with an increase in the fitted value of $\tau_1$. This effect cannot be explained by the change of the charge state of the vacancy defect induced by a decrease of the measurement temperature, since a lowering of the temperature moves the Fermi level closer to the conduction band, which would imply a more negatively charged defect and thus an increase of the $I_2$ value. Neither can it be explained by the temperature dependence of the rate of positron trapping into the vacancy states discussed in Sec. III A, because neutral and negatively charged vacancies have either a constant or $T^{-0.5}$ dependence on temperature, respectively, in which case a decreasing $I_2$ with decreasing temperature cannot be obtained. In the following sections, we discuss some possibilities that may introduce such a low-temperature behavior, namely, (a) the presence of a negatively charged impurity acting as a positron shallow trap, (b) the charge state transition of the carbon vacancy $V_C$, and (c) the $T^{-0.5}$ temperature dependence of the positron trapping coefficient of $V_C$.

#### 1. Positron shallow trap

In Ref. 11, we attributed this low-temperature effect to a positron shallow trap. A positron shallow trap is a hydrogen-like state formed by a positron binding to a negative ion. The binding energy of such a trap is typically about 10–100 meV, which is small compared to that of about 1 eV for a vacancy type defect. As the positron is weakly bound to the negative ion, the lifetime of the positron is very close to the bulk state positron lifetime. As the temperature decreases, thermal detrapping of the positron from the shallow trap becomes insignificant, and thus more positrons annihilate in the shallow trap state. This is reflected by the decrease of $I_2$ and the corresponding increase of $\tau_1$, as shown in Fig. 3. According to a model involving competitive positron trapping into a shallow trap and a vacancy-type defect, which is presented in Ref. 11, the concentration and the binding energy of the shallow trap was found to be $c_{si} = 8 \times 10^{13} \text{ cm}^{-3}$ and $E_b = 13 \text{ meV}$. The fitted curves of $I_2$ and $\tau_1$ shown as the solid lines in Figs. 3(a) and 3(b), respectively. Although we can explain the low-temperature trapping by the shallow trap model, it is important in making a comprehensive discussion to consider some other alternative possibilities.

#### 2. Charge state transition of $V_C$

Brauer et al.\textsuperscript{21} calculated the lifetime value of $V_C$ as 153 ps, which, like the shallow trap state, is very close to the bulk
lifetime. This implies that even if a carbon vacancy exists, we may not be able to separate it from the observed $\tau_1$ component. If the carbon vacancy has an ionization level (0/+) or (-/0) close to the conduction band, then the moving up of the Fermi level induced by the lowering of the temperature may cause the carbon vacancy to capture an electron, thus becoming more negative and positron attractive. The increased positron trapping into the carbon vacancy would result in a decrease of $V_S$ and $V_C/V_S$, trapping, and a reduced value of $I_2$.

In order to test the validity of this interpretation, Hall-effect measurements were performed on the sample at temperatures ranging from 30 to 300 K. The Fermi-level position was calculated using the equation $n = n_C \exp(-E_C/E_F)kT$, where $n_C$ is the effective density of states of conduction band, and $n_C = \frac{2 \pi m^*_d kT}{\hbar^2}$ and $m^*_d = (m^* m^*_e)^{1/2}$. The values of $m^*_e$ and $m^*_i$ were taken as 0.25 and 1.5 (see Ref. 28, and references therein). The calculated Fermi-level position $E_C - E_F$ is shown in Fig. 3(c). It was found that $E_C - E_F$ in general dropped with decreasing temperature from 0.11 eV at 300 K. A transition was found at the temperature range of 80–100 K, in which $E_C - E_F$ decreased from 0.078 to 0.053 eV. At lower temperatures, the Fermi level was found to pin at $E_C - E_F = 0.053$ eV. The transition found at $T = 100$ K results from a “freeze out” of the carriers onto the main nitrogen donor. The rapid change in the Fermi level at this temperature may imply a charge state transition of a defect. Although this transition temperature is close to the transition temperature of the positron lifetime data, it is probable that they are not the same transition. This is because the transition seen in the Hall measurement is fully completed by $T = 80$ K, and then the Fermi level remains constant, in contrast to the variation in $I_2$ and $\tau_1$ which persists down to 10 K.

Zywietz et al. performed first-principles calculations on the neutral and charged carbon vacancy in 4H-SiC. According to their calculation, the carbon vacancy exhibited a negative-U behavior. The ionization levels (-/0) and (-/-) were at $E_V + 2.81$ eV ($E_C - E_F = 0.29$ eV) and $E_V + 2.38$ eV ($E_C - E_F = 0.72$ eV), respectively. As compared with the measured Fermi-level position shown in Fig. 3(c), this implies that $V_C$ in the sample is always in a (-/-) charge state, and probably has no charge transition in our measuring temperature range. Furthermore, Dannefaer et al. studied electron-irradiated 6H-SiC with positron lifetime and Doppler broadening techniques. A 160-ps lifetime component was found, and attributed to the carbon vacancy. From their reported data down to a temperature of 30 K, no charge state transition was observed. Thus we tend not to favor this model, which involves the transition of the $V_C$ charge state as the temperature decreases.

3. $T^{-0.5}$ dependence of positron trapping coefficient of negatively charged $V_C$

Another effect requiring consideration is whether the carbon vacancy in a negatively charged state could bring about the observed low-temperature $I_2$ and $\tau_1$ behaviors. As mentioned in Sec. III B 2, according to the calculation of Zywietz et al., and our measured Fermi-level position, the charge state of the $V_C$ in our sample is 2, which implies a positron trapping coefficient dependence of $T^{-0.5}$. As the lifetime value of positron annihilating in $V_C$ is very close to that of the bulk, this lifetime component could be indistinguishable from the bulk lifetime. Thus, if a carbon vacancy does exist, as the measurement temperature decreases the positron trapping rate into $V_C$ increases; consequently $I_2$ decreases and $\tau_1$ increases in much the same manner as in a nonopen volume positron shallow trap, as discussed in Sec. III A.

In a case when the lifetime value of a positron trapping center (i.e., $V_C$) is indistinguishable from the bulk lifetime and there is another well-separable long lifetime component, the positron trapping rate into the carbon vacancy $\kappa_{V_C}$ and the observed $\tau_{1,\text{expt}}$ can be expressed as

$$\kappa_{V_C} = \frac{\tau_{1,\text{expt}}(\lambda_b - I_{2,\text{expt}}\lambda_{2,\text{eff}}) - I_{1,\text{expt}}}{\tau_{V_C} - \tau_{1,\text{expt}}},$$ \hspace{1cm} (7)

$$\kappa_{2,\text{eff}} = \frac{I_{2,\text{expt}}}{I_{1,\text{expt}}} (\lambda_b - \lambda_{2,\text{eff}} + \kappa_{V_C}),$$ \hspace{1cm} (8)

$$\tau_{1,\text{mod}} = \frac{1 + (\kappa_{V_C}/\lambda_{V_C})[1 + \kappa_{2,\text{eff}}/(\lambda_b - \lambda_{2,\text{eff}} + \kappa_{V_C})]}{\lambda_b + \kappa_{V_C} + \kappa_{2,\text{eff}}}.$$ \hspace{1cm} (9)

We have calculated the positron trapping rate into the carbon vacancy $\kappa_{V_C}$ at $T < 80$ K using Eq. (7), while taking $\tau_{V_C} = 153$ ps, $\tau_0 = 141$ ps, and $\tau_{2,\text{eff}} = 200$ ps. The results of log $\kappa_{V_C}$ as a function of the log $T$ is plotted in Fig. 4. The slope of the fitted straight line in Fig. 4 was found to be $-0.52 \pm 0.01$, which is very close to the predicted value of $-0.5$ with our present assumption. With these results, the modeled $\tau_{1,\text{mod}}$ was calculated and plotted in Fig. 3(b). The modeled curve also shows a good representation of the experimental data.

We now consider whether the annealing behavior as shown in Figs. 3(a) and 3(b) can help in distinguishing any of the above models. As the annealing temperature goes up to 650 °C, the observed $I_2$ becomes independent of the temperature, indicating that defect center responsible for the
low-temperature anomaly has been annealed out. No further change was observed as the annealing increased up to 1400 °C. In previous sections, the low-temperature behavior observed in samples with annealing temperatures lower than or equal to 400 °C originated from two possibilities, namely, the presence of a positron shallow trap or the presence of a negative carbon vacancy. The annealing out of this low-temperature defect site is thus due to the removal of either a carbon vacancy or a charge neutralization reaction of a positron shallow trapping negative impurity.

IV. DISCUSSION AND CONCLUSION

In the analysis of the lifetime spectra, the following observations have been made. In the as-grown n-type 6H SiC sample, we observed a lifetime component \( \tau_2 = 200 \) ps which was attributed to positrons annihilating from \( V_{Si} \) and \( V_C V_{Si} \), which have lifetime values lower and greater than 200 ps, respectively. At annealing temperatures of 650 °C or above, the observed \( \tau_2 \) changed to about 232-ps as the silicon vacancy was annealed out. This 232-ps lifetime component was attributed to a positron purely annihilating from \( V_C V_{Si} \). This value is close to the \( V_C V_{Si} \) lifetime value of 214 ps calculated by Brauer et al.\(^{23}\) and the 235-ps lifetime component found after Ge implantation, which was attributed to a \( V_F V_{Si} \) divacancy.\(^{10}\)

In an earlier study,\(^{11}\) we also performed lifetime measurements on as-grown p-type 6H-SiC as a function of the measurement temperature. A temperature-independent lifetime component of 225±11 ps was observed. The Fermi level of this p-type sample at room temperature is estimated to have been \( E_F + 0.045 \) eV. The \((++/+)\) level of \( V_{Si} \) was calculated to be \( E_F + 0.17 \) eV by Zywietz et al.\(^{26}\) As already pointed out by Ling et al.\(^{11}\) and further supported by the result of Zywietz et al., \( V_{Si} \) in the p-type sample should be positively charged, which implies that the 225-ps observed component was totally free from any positrons annihilating from \( V_{Si} \). In this respect it is noted that the as-grown p-type lifetime data (225±11 ps) are statistically consistent with that of the n-type sample annealed at temperatures of 650 °C or above (232±5 ps) as regards the long lifetime component. This supports our viewpoint, namely, that the 232-ps lifetime component observed in the present annealed n-type sample originates from the \( V_C V_{Si} \) divacancy. Assuming the correctness of this interpretation, and considering that the positron trapping rate of \( V_C V_{Si} \) is found to be independent of the measurement temperature, the Si+C divacancy should be a neutral defect. Moreover, it can also be stated that the \( V_C V_{Si} \) divacancy is stable at an annealing temperature of 1400 °C. These observations are consistent with the report of Polity et al.\(^{29}\) in which the annealing of electron irradiated n-type 6H SiC was monitored by the average positron lifetime without performing spectral decomposition. These authors reported a positron trapping center, probably a divacancy which annealed out in the region 920 °C–1470°.

For the as-grown and 400 °C annealed sample, our study revealed that the observed \( \tau_2 \) decreases with decreasing measuring temperature, with a corresponding increase in \( \tau_1 \), at temperatures lower than 80 K. This low-temperature behavior can be attributed to the presence of either a positron shallow trap or a negatively charged carbon vacancy. This feature was found to anneal out in the temperature range 400–650 °C. Kawasuso et al.\(^{8}\) and Polity et al.\(^{29}\) studied electron-irradiated n-type 6H SiC, though their electron dosage and implanting energy were different. In Kawasuso et al.’s work,\(^{8}\) the lifetime spectra were decomposed into two lifetime components. The experimental \( \tau_1 \) values were found to deviate from the simple trapping model, and this was attributed to the presence of the carbon vacancy. This observed carbon vacancy was annealed out at 450 °C. In Polity et al.’s work\(^{29}\) the average lifetime was measured as a function of the annealing temperature. The average lifetime was found to slightly increase with increasing annealing temperature in the range of 480–930 °C, and this was attributed to the annealing out of a shallow trap. The present study and these previous studies share a common observation that in an n-type 6H SiC sample, there is a positron trapping site with characteristic lifetime close to the bulk that competes with trapping into the longer lifetime component (i.e., the silicon vacancy and \( V_C V_{Si} \)). It is unlikely that positron lifetime data can on their own distinguish this positron trapping site, although its low temperature trapping behavior shows it to be a negatively charged site. We are inclined, however, to believe the center to be a negatively charged carbon vacancy. This is because it is possible for a vacancy to be annealed out, whereas it is difficult to imagine a mechanism for charge neutralization of an ionized acceptor impurity.

Photoluminescence studies of ion-implanted 6H SiC show a \( D_1 \) spectrum which is thermal stable up to 1700 °C,\(^{12}\) while DLTS in 6H SiC reveals a series of deep levels labeled as \( Z_1/Z_2, E_1/E_2 \) and E3/E4.\(^{1−4}\) In Zhang et al.’s work,\(^{14}\) \( Z_1/Z_2 \) was found to be thermally persistent up to 1700 °C, causing them to relate the \( Z_1/Z_2 \) level to the \( D_1 \) spectrum and to the \( V_C V_{Si} \) divacancy. Gong et al.\(^3\) and Aboelfotoh and Doyle\(^4\) studied electron-irradiated 6H SiC, and obtained a different result. Similar to the findings of Zhang et al., Gong et al. and Aboelfotoh and Doyle also observed the deep levels \( Z_1/Z_2 \), but their \( Z_1/Z_2 \) annealed out at a temperature of 850 °C and less than 1150 °C, respectively. However, in all these DLTS studies \( E_1/E_2 \) deep levels are found to have a high thermal stability. In Gong et al.’s study, \( E_1/E_2 \) started to anneal out at a temperature of about 1500 °C, and the level was attributed to a \( V_C V_{Si} \) divacancy, while in Aboelfotoh and Doyle’s work \( E_1/E_2 \) persisted after a 1000 °C anneal, although in this case the levels were attributed to a negative carbon vacancy related defect.

In Gong et al.’s work,\(^3\) it was reported that the observed level \( E_1 \) (referred to as \( ED_3 \) in Ref. 3) in electron-irradiated n-type 6H SiC has two annealing stages. The concentration of \( ED_3 \) first decreased at 700 °C to a certain plateau value which was sustained up to 1600 °C. It was suggested that the \( ED_3 \) deep level consisted of two defects, whereas the first one (\( ED_{3L} \)) annealed out at 700 °C and the second one (\( ED_{3H} \)) annealed out above 1600 °C. As this \( ED_{3H} \) had the same annealing behavior as \( E_2 \) (referred to as \( ED_4 \) in Ref. 3), and the ratio of \( ED_{3H} \) to \( ED_4 \) is the same for different electron-implanting dosages, it was concluded that \( ED_{3H} \) and \( ED_4 \) were due to the same defect taking up different site configurations, and these were attributed to the \( V_C V_{Si} \) divacancy. Frank et al.\(^{30}\) studied He-implanted 6H SiC with DLTS and photoluminescence (PL) in order to correlate the DLTS deep levels to the PL lines. It was found...
that at an annealing temperature of 1400 °C, the $E_1/E_2$ observed in the DLTS measurement and the $D_1$ lines found in the PL measurement were found to persist. On the other hand, the $Z_1/Z_2$ DLTS signal and a 4349 Å PL line were found to simultaneously extinguish at this annealing temperature. It was suggested that the $E_1/E_2$ DLTS signal and the $D_1$ PL lines originated from the same defect. As our present lifetime data show that the concentration of the $V_CV_{Si}$ divacancy remains unchanged at an annealing temperature of 1400 °C, this implies that $Z_1/Z_2$ and thus the 4349 Å are not related to the $V_CV_{Si}$ divacancy. It is still plausible to maintain the viewpoint that the thermally stable $E_1/E_2$ observed in the DLTS and the corresponding $D_1$ in PL are associated with the $V_CV_{Si}$ divacancy.

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